



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 31, 2026	
IGI Report Number	LG787675701
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.32 - 7.36 X 4.63 MM

GRADING RESULTS

Carat Weight	1.56 CARAT
Color Grade	H
Clarity Grade	VVS 2
Cut Grade	EXCELLENT

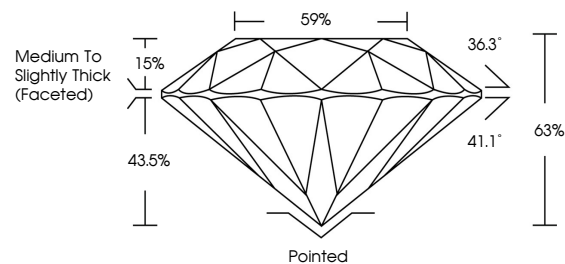
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG787675701

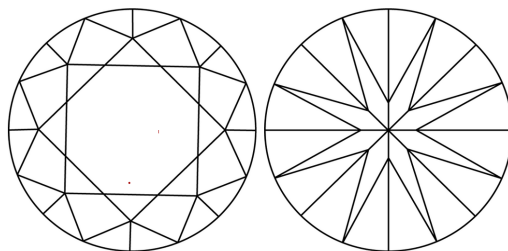
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG787675701
Report verification at igi.org

PROPORTIONS

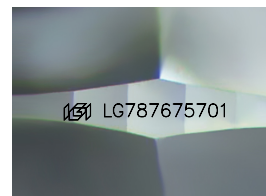


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

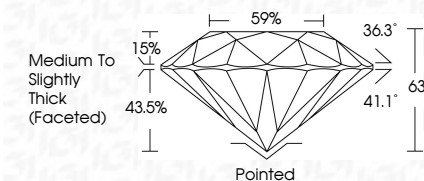
FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	(G) LG787675701
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.	
Type IIa	



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www.igi.org

March 31, 2026	1.56 CARAT
GI Report No. LG7676701	VVS 2
ROUND BRILLIANT	EXCELLENT
	63%
	59%
	Medium to Slightly Thick (Feetted)
	Polished
	EXCELLENT
	NONE
	#69 LG7676701
	Comments:
	This Laboratory Grown Diamond was analyzed by the Thermal Vapor Deposition (TVD) growth process.
	Type IIG